

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/550,459 Confirmation No. : 4620  
First Named Inventor : Decams, Jean-Manuel  
Filed : December 12, 2006  
TC/A.U. : 1792  
Examiner : Michael G. Miller  
  
Docket No. : 104003.B130130  
Customer No. : 23911  
  
Title : Method for CVD Deposition of a Silver Film on a Substrate

AMENDMENT AND RESPONSE UNDER 37 C.F.R. § 1.111

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In complete response to the non-final Office Action dated April 4, 2008, Applicants submit herewith a Petition for a three month extension of time, extending the period of response from July 4, 2008 to October 4, 2008, and the following Response.

**Amendments to the Claims** are reflected in the Listing of Claims, which begins on page 2 of this Response.

**Remarks** begin on page 4 of this Response.